

(12) INTERNATIONAL APPLICATION PUBLISHED UNDER THE PATENT COOPERATION TREATY (PCT)

(19) World Intellectual Property Organization International Bureau



(43) International Publication Date
21 May 2004 (21.05.2004)

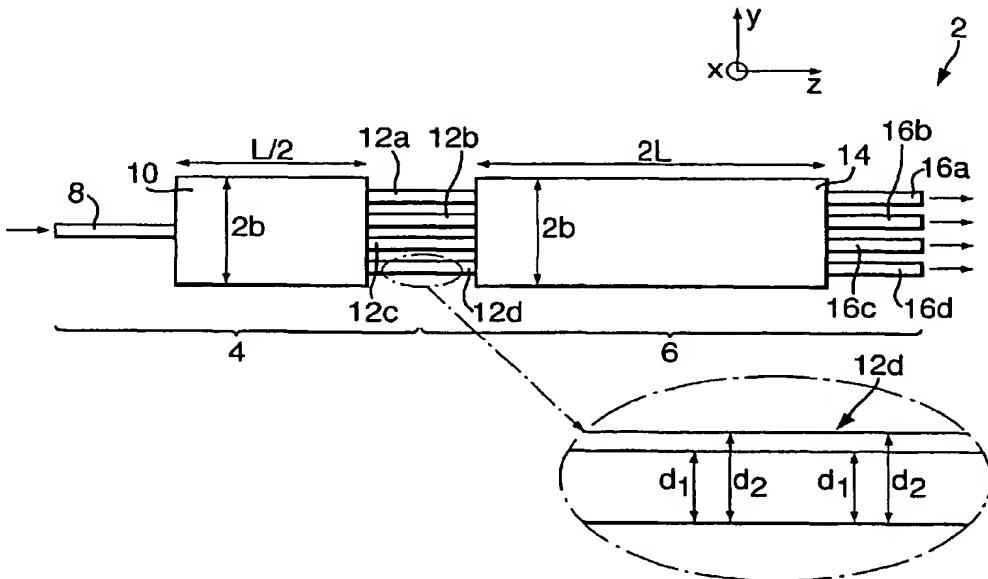
PCT

(10) International Publication Number
WO 2004/042443 A1

- (51) International Patent Classification⁷: G02B 6/28, Michael [GB/GB]; Qinetiq Limited, malvern technology centre, St Andrews Road, Malvern, Worcestershire WR14 3PS (GB). MCNIE, Mark, Edward [GB/GB]; QinetiQ Limited, Malvern Technology Park, St Andrew's Road, Malvern, Worcestershire WR14 3PS (GB).
- 6/12, 26/00
- (21) International Application Number: PCT/GB2003/004723
- (22) International Filing Date: 3 November 2003 (03.11.2003) (74) Agent: DAVIÈS, P; D/IP QinetiQ Formalities, Cody Technology Park, A4 Building, Room G016, Ively Road, Farnborough, Hampshire GU14 0LX (GB).
- (25) Filing Language: English (81) Designated States (*national*): AE, AG, AL, AM, AT, AU, AZ, BA, BB, BG, BR, BW, BY, BZ, CA, CH, CN, CO, CR, CU, CZ, DE, DK, DM, DZ, EC, EE, EG, ES, FI, GB, GD, GE, GH, GM, HR, HU, ID, IL, IN, IS, JP, KE, KG, KP, KR, KZ, LC, LK, LR, LS, LT, LU, LV, MA, MD, MG, MK, MN, MW, MX, MZ, NI, NO, NZ, OM, PG, PH, PL, PT, RO, RU, SC, SD, SE, SG, SK, SL, SY, TJ, TM, TN, TR, TT, TZ, UA, UG, US, UZ, VC, VN, YU, ZA, ZM, ZW.
- (26) Publication Language: English
- (30) Priority Data: 0225595.8 2 November 2002 (02.11.2002) GB (84) Designated States (*regional*): ARIPO patent (BW, GH, GM, KE, LS, MW, MZ, SD, SL, SZ, TZ, UG, ZM, ZW), Eurasian patent (AM, AZ, BY, KG, KZ, MD, RU, TJ, TM), European patent (AT, BE, BG, CH, CY, CZ, DE, DK, EE, ES, FI, FR, GB, GR, HU, IE, IT, LU, MC, NL, PT, RO, SE,
- (71) Applicant (*for all designated States except US*): QINETIQ LIMITED [GB/GB]; Registered Office, 85 Buckingham Gate, GB-London SW1E 6PD (GB).
- (72) Inventors; and
- (75) Inventors/Applicants (*for US only*): JENKINS, Richard,

[Continued on next page]

(54) Title: HOLLOW CORE MULTI-MODE INTERFERENCE OPTICAL DEVICE



(57) Abstract: A hollow core multi-mode interference (MMI) device is described that comprises a multi-mode waveguide (10, 14) optically coupled to at least two fundamental mode waveguides (8, 12, 16). The device is characterised in that it comprises a means for varying the internal cross-sectional dimensions of a portion of one or more of said at least two fundamental mode waveguides. In particular, the side wall of a fundamental mode waveguide having a substantially square cross-section can be moved using micro-electro mechanical systems (MEMS). Various optical routing devices incorporating such MMI devices are described.

WO 2004/042443 A1



SI, SK, TR), OAPI patent (BF, BJ, CF, CG, CI, CM, GA,
GN, GQ, GW, ML, MR, NE, SN, TD, TG).

Declaration under Rule 4.17:

— *of inventorship (Rule 4.17(iv)) for US only*

Published:

— *with international search report*

For two-letter codes and other abbreviations, refer to the "Guidance Notes on Codes and Abbreviations" appearing at the beginning of each regular issue of the PCT Gazette.

HOLLOW CORE MULTI-MODE INTERFERENCE OPTICAL DEVICE

This invention relates to a multi-mode interference (MMI) device, and in particular to optical routing devices incorporating one or more multi-mode interference 5 devices.

US5410625 describes a multi-mode interference (MMI) device for beam splitting and recombining. The device comprises a first coupling waveguide and two or more second coupling waveguides that are optically connected to a central multi-mode 10 waveguide region. The coupling waveguides operate only in fundamental mode, and the physical characteristics of the coupling and multi-mode waveguide regions are selected such that modal dispersion within the central multi-mode waveguide region provides for a single beam of light input in to the first coupling waveguide to be split into the two or more second coupling waveguides. The device may also be operated 15 in reverse as a beam combiner.

Variations and improvements to the basic MMI devices of US5410625 are also known. US5379354 describes how variation of input waveguide location can be used to obtain a multi-way beam splitter that provides division of the input radiation 20 into outputs beams having differing intensities. Use of MMI devices to form laser cavities has also been demonstrated; for example see US5675603.

US5428698 describes various signal routing devices incorporating hollow and solid-core MMI devices. In one such device, the outputs of an MMI beam-splitter device 25 are optically connected via a set of relay waveguides to the inputs of an MMI beam-recombiner device. The arrangement is such that a single laser beam input to the MMI beam-splitter can be transferred to any one or more of the output waveguides of the MMI beam recombiner by the application of different sets of phase shifts to light as it propagates through the relay waveguides. A so-called "star coupler" 30 device is also described in which a single MMI device is configured to operate as both the beam splitter and beam recombiner.

US5428698 teaches how reflective or transmissive phase shifting means may be used to introduce the required relative phase shifts to light propagating through the relay waveguides. In hollow core devices, the transmissive phase shifting means (typically electro-optic modulators) are located in the hollow channels defining the 5 relay waveguides. The use of hollow core relay waveguides that incorporate moveable mirrors to alter the path length of the relay waveguides, thereby operating as reflective phase shifting means, are also described.

A disadvantage of hollow core signal routing devices incorporating transmissive 10 phase shifting means is that the total optical power that can be passed through the device is limited by the optical power that the transmissive phase shifting element can handle. The signal routing devices incorporating reflective phase shifters as described in US5428698 also have certain disadvantages. For example, an overlap of the beams propagating in the relay waveguide is required and can introduce cross-talk that reduces the overall efficiency of the device. Alignment of the mirror 15 position and accurate control of mirror movement is also critical; any alignment errors will significantly increase optical losses in the relay waveguides thereby reducing the overall efficiency of the routing device.

20 According to a first aspect of the present invention a hollow core multi-mode interference (MMI) device comprises a multi-mode waveguide optically coupled to at least two fundamental mode waveguides, and is characterised in that the device comprises a means for varying the internal cross-sectional dimensions of a portion of one or more of said at least two fundamental mode waveguides.

25

Variation of the cross-sectional dimensions of the fundamental mode waveguides in an MMI device of the present invention provides a convenient means of controlling the phase of light as it passes through a certain length of the fundamental mode waveguide. This phase shift arises because the variation in the waveguide cross- 30 sectional dimension alters the wavelength (or phase coefficient) of the fundamental mode of the waveguide. The amount of variation required to impart the required phase shift is described in more detail below with reference to figure 5.

As an example, consider an MMI device operating as a beam splitter. A single incident beam could be split into N (where $N \geq 2$) beams by modal dispersion in the multi-mode waveguide region and each of these beams could be coupled into a 5 fundamental mode waveguide. Variation of the cross-sectional dimensions of one or more of the fundamental mode waveguides would then permit phase differences to be introduced between the N beams propagating through each fundamental mode waveguide. Similarly, in an MMI N-beam recombiner, control of the relative phase of beams prior to recombination in the multi-mode region would be possible.

10

Optical devices (routers, switches etc) fabricated using an MMI device of the present invention do not require the inclusion of transmissive phase shifting elements. This enables higher optical powers to be handled. Previously, moveable mirror phase shifters were implemented using highly reflective mirrors arranged in an optical 15 layout in which movement of the mirror effectively altered the path length of the fundamental mode waveguide(s). As grazing angle reflectivity is inherently higher than near normal incidence reflectivity, the requirement to provide highly reflective mirrored surfaces is overcome by the present invention. Furthermore, the present invention does not require the specific optical layouts disclosed in the prior art to 20 implement moveable mirror phase shifting.

Variation of the internal cross sectional dimensions of the fundamental mode waveguide may be achieved in a variety of ways. In the examples described with reference to figures 1 and 3, light propagates through a substantially square cross-section fundamental mode waveguide along the z-axis. The cross-section of the waveguide is thus in the x-y plane, and movement of a side wall in the y-axis direction (i.e. changing the width of the waveguide) varies the cross sectional 25 dimensions of the waveguide. Alternatively, or additionally, the waveguide dimensions could be varied in the x-direction (i.e. the height of the waveguide could 30 be altered).

It should be noted that when hollow core optical waveguide structures are produced, the hollow core is likely to fill with air. Herein the refractive index of the core is thus assumed to be that of air at atmospheric pressure and temperature (i.e. $n \approx 1$). However, this should be seen in no way as limiting the scope of this invention. The 5 hollow core may contain any fluid (for example an inert gas such as nitrogen) or be a vacuum. The term hollow core simply means a core which is absent any solid material.

Advantageously, at least one of the fundamental mode waveguides has a 10 substantially square cross-section. The term substantially square cross-section should be taken to include waveguides that are approximately square albeit having some degree of side wall movement. As described below with reference to figures 1 and 3, one or more of the hollow core substantially square fundamental mode waveguides could be formed in a base portion of material and a lid placed thereon. 15 The hollow waveguides would have side walls, and one or both of these could be moveable to allow alteration of the cross sectional dimensions (e.g. the width) of the waveguide.

Although substantially square waveguides are preferred for ease of fabrication, a 20 skilled person would appreciate that the invention could be implemented using fundamental mode waveguides of any shape (e.g. v-shaped, rectangular, circular, elliptical etc.).

Conveniently, the internal surfaces of the hollow core waveguides are coated with 25 reflective material.

As described in WO 03/065088 (the contents of which are incorporated herein by reference thereto) a reflective coating may also be applied to the surfaces forming the hollow core waveguides to enhance reflectivity at the wavelength of operation 30 and thereby reduce optical losses associated with the device.

Conveniently, the hollow core waveguides are formed in semiconductor material; for example silicon or III-V semiconductor materials such as GaAs, InGaAs, AlGaAs or InSb. The semiconductor material may be provided in wafer form. Advantageously, the devices are formed using semiconductor micro-fabrication techniques. Preferably, such micro-fabrication techniques provide fundamental mode waveguides having cross-sections of less than 3mm, or more preferably less than 1mm

It should be noted that the devices may be produced in a variety of ways. The 10 waveguides may be formed in unitary pieces of material, they may be formed from two separate pieces of material (such as a base and a lid) or they may be formed from a plurality of different pieces of material (e.g. separate sections of material that, when located together, define the required fundamental mode and multi-mode waveguide regions).

15

Advantageously, the means for varying the cross-sectional dimensions of a portion of said fundamental mode waveguide comprises micro-electro-mechanical system (MEMS) actuation means.

20

For example, the waveguides may comprises side walls which are moveable using MEMS technology. The moveable portion of the waveguide may be formed as an integral part of the substrate or fabricated separately and integrated in a hybrid fashion to form the moveable portion of the waveguide. In the case of a device formed from a base and lid, the MEMS means could be formed on the lid section 25 and integrated with the base during the lidding process.

30

Alternatively, the means for varying the internal cross-sectional dimensions of a portion of said fundamental mode waveguide may be arranged such that the fundamental mode waveguide dimensions are variable in response to an externally applied force. A motion or displacement sensor may thus be provided in which an external force is used to alter the internal cross-sectional dimensions of the fundamental waveguide.

According to a second aspect of the present invention a device for routing radiation comprising at least one device according to the first aspect of the present invention.

- 5 According to a third aspect of the present invention, an optical router comprises at least one fundamental mode input waveguide optically coupled to an MMI beam splitter, the MMI beam splitter also being optically coupled, via two or more relay waveguides, to an MMI beam combiner having two or more fundamental mode output waveguides, wherein the relay waveguides comprise a means for altering the relative phases between the two or more beams propagating through the relay waveguides such that radiation received from the fundamental mode input waveguide may be selectively routed to any one of the two or more fundamental mode output waveguides, and is characterised in that the means for altering the relative phases between the two or more beams comprises a means for varying the cross-sectional dimensions of a portion of one or more of the relay waveguides.
- 10
- 15

- According to a fourth aspect of the present invention an optical router comprises a multi-mode waveguide region optically coupled to a plurality of input/output fundamental mode waveguides and a plurality of relay waveguides, the router being configured to receive a beam of radiation via one of the plurality of input/output fundamental mode waveguides and, via modal dispersion in the multi-mode waveguide region, to divide the received beam into a plurality of beams which are coupled in the relay waveguides, wherein the relay waveguides comprise a means for altering the relative phases between the plurality of beams and each relay waveguide is terminated with a reflective means such that radiation is returned to the multimode waveguide region and, dependent on the relative phases of the returned beams, routed to any one of the input/output fundamental mode waveguides, characterised in that the means for altering the relative phases between the plurality of beams comprises a means for varying the cross-sectional dimensions of a portion of one or more of the relay waveguides.
- 20
- 25
- 30

According to a fifth aspect of the invention, an optical phase shifter comprises a hollow core optical waveguide, characterised in that the phase shifter comprises means for varying the internal cross-sectional dimensions of a portion of said hollow core optical waveguide. The optical phase shifter may be used in an MMI device, or
5 any optical device where a phase shifting function is required.

The invention will now be described, by way of example only, with reference to the following figures in which;

- 10 figure 1 shows an optical routing device according to the present invention,
figure 2 illustrates the propagation of radiation in a device of the type described with reference to figure 1,
- 15 figure 3 shows a star coupler optical routing device according to the present invention,
figure 4 illustrates the propagation of radiation in a device of the type described with reference to figure 3, and
20 figure 5 shows a theoretical plot of the amount of waveguide side-wall movement required to impart a π phase shift to light of $1.55\mu\text{m}$ wavelength propagating through a 10mm long fundamental mode waveguide.
- 25 Referring to figure 1, an optical routing device 2 according to the present invention is shown. The optical routing device 2 comprises a multi-mode interference (MMI) beam splitting portion 4 and an MMI beam recombining portion 6.
30 The beam splitting portion 4 comprises a fundamental mode input waveguide 8 that is optically linked to a multi-mode waveguide region 10. The dimensions of the multi-mode waveguide region 10 are selected such that modal dispersion causes the fundamental mode beam received from the input waveguide 8 to be substantially

equally divided between the four fundamental mode relay waveguides 12a to 12d (referred to collectively as 12).

The multi-mode waveguide region 14 of the beam recombining portion 6 receives
5 light from each of the four fundamental mode relay waveguides 12. The dimensions
of the multi-mode waveguide region 14 are selected such that, depending on the
relative phase of the light received from the relay waveguides, a fundamental mode
may be excited in any one or more of the fundamental mode output waveguides 16a
to 16d (referred to collectively as 16):

10 A detailed description of the necessary dimensions of the multi-mode regions 10 and
14 can be found elsewhere; for example see US5428698.

Control of the relative phase of light injected into the multi-mode waveguide region
15 14 from the relay waveguides is achieved by varying the width (d) of one or more of
the relay waveguides by moving one of the side walls that forms the hollow
waveguide. A detailed description of the amount of side wall movement required to
impart a required phase shift is described in more detail with reference to figure 5.
An expanded view of the relay waveguide 12d is also given in figure 1, and
20 illustrates how the width of the relay waveguide can be varied between d_1 and d_2 .

A person skilled in the art would recognise that one side wall could be moved as
shown in figure 1, or that the device could be configured to provide movement of
both side walls. It would also be recognised by the skilled person that a portion of
25 the relay waveguide could be varied in width whilst the width of the remaining
portion is kept constant or varied by a different amount. The phase shift introduced
by side wall movement will depend on both the amount of side wall movement and
also the length of the portion of the side wall which is moved; this is described in
more detail below with reference to figure 5. Control of side wall movement in the
30 relay waveguides can thus be used to introduce relative phases shifts such that the
fundamental mode beam to be coupled into any one or more of the fundamental
mode output waveguide 16 as required.

- As described above, variation of the relay waveguide width provides a convenient way of introducing a relative phase shift between the light propagating through the relay waveguides. A device of the present invention can thus handle higher optical power than routers of the type described in US5428698 that employ transmissive electro-optic modulators. Furthermore, certain disadvantages associated with the use of moveable mirror phase shifting means (e.g. the requirement for beam cross over and the precision of mirror alignment) are also mitigated.
- 5
- 10 The relay waveguide width may be controllably varied (e.g. using an MEMS actuator) to impart a desired phase shift as described above. Alternatively, the waveguide width may be varied by an externally applied force and the resulting phase shift measured. A motion or displacement sensor may thus be provided in which an external force is used to alter the internal cross-sectional dimensions of the
- 15 waveguide.

In particular, a motion and/or displacement sensor arrangement could be readily implemented using a device of the kind described with reference to figure 1 but having only two relay waveguide and two output waveguides. In such an arrangement, the phase shift imparted by changing the width of a relay waveguide by application of an external force may be used to alter the proportion of light split between two output waveguides. In such a movement sensing device, a sufficiently large change in guide width (as described with reference to figure 5 below) could result in complete switching of the output beam from one output guide to the other (i.e. a π phase shift). This switching effect could be measured using photodetectors; such photo-detectors may be integrated into the device. Multiples of the π phase shift could be counted as cycles of the output beam/signals, whilst fractions of the increment could be measured in terms of the relative output powers directed to the two output waveguides.

20

25

Referring to figure 2, the basic principle underlying the multi-mode interference effect that provides beam splitting and beam recombination in a device of the type described with reference to figure 1 is shown.

- 5 Figure 2a illustrates transverse intensity profiles of electromagnetic radiation at four positions along the multi-mode waveguide region 10 of the MMI beam splitting portion 4. It can be seen that the fundamental mode input beam entering the multi-mode waveguide region 10 via the input waveguide 8 is split into four equal intensity beams that are coupled into the relay waveguides 12.

10

Figures 2b and 2c show transverse intensity profiles of electromagnetic radiation at thirteen positions along the multi-mode waveguide region 14 of the MMI beam recombining portion 6 with two different sets of phase shift applied to light propagating through the relay waveguides 12.

15

- Figure 2b illustrates how a first set of phase shifts applied by the relay waveguides 12 allows radiation to be routed to output waveguide 16a, whilst figure 2c illustrates how a second set of phase shifts will route radiation to output waveguide 16b. Radiation may also be routed to output waveguides 16c and 16d by application of appropriate phase shifts. More details concerning the appropriate phase shifts can be found in US5428698.

- 25 Referring to figure 3, a star coupler routing device 22 of the present invention is shown. The device 22 comprises input/output waveguides 24a to 24d (referred to collectively as 24), a multi-mode waveguide region 26 and relay waveguides 28a to 28d (referred to collectively as 28). Each of the relay waveguides 28a to 28d has a moveable side wall and is terminated by fixed mirrors 30a to 30d (referred to collectively as 30). The device 22 can thus be seen to be essentially half of the device 2 with fixed mirrors added. A detailed description of the required dimensions 30. of the multi-mode region of such star coupler devices is also given elsewhere; for example see US5428698.

- In operation, radiation enters the multi-mode waveguide region 26 via any one of the input/output waveguides 24 and modal dispersion in the multi-mode waveguide region 26 causes the radiation to be divided into four equal intensity beams that are coupled in to each of the relay waveguides 28. The relative phase of the fundamental mode radiation returned to the multi-mode region by each relay waveguide after reflection by the fixed mirrors 30 is controlled by varying the width of the relay waveguides. A calculation of the amount of side wall movement required to impart the required phase shifts is described in more detail below.
- 5 It should be noted that the beam passes through the relay waveguides in the star coupler device twice (i.e. before and after reflection from the mirror). Hence the induced phase shift is double that which would be produced by a single passage through the waveguide. In a manner analogous to that described with reference to figure 1, appropriate selection of the relative phase shift imparted by the relay waveguides thus allows an output beam to be routed from the device via any one or 10 more of the input/output waveguides 24.
- 15 Referring to figure 4, transverse intensity profiles of electromagnetic radiation propagating through the multi-mode waveguide region 26 of the device described 20 with reference to figure 3 are shown.
- Figure 4a illustrates how fundamental mode radiation coupled into the multi-mode waveguide region 26 from the input/output waveguide 24d is split into four equal intensity beams by modal dispersion. Figures 4b and 4c illustrate how modal dispersion of the four equal intensity beams, after appropriate relative phase shifts 25 are applied by the relay waveguides, can form a beam in a location such that it is coupled into the input/output waveguides 24b or 24a respectively. Again, it should be noted that the application of appropriate phase shifts by the relay waveguide can route an output signal to any one or more of the input/output waveguides 24.
- 30 Although figures 1 and 3 show devices providing a four way splitting/recombinining function, the invention is generally applicable to MMI devices providing an N-way

splitting/recombinining function where N is greater than or equal to two. Details on the dimensions required for N-way routing are described elsewhere; for example see US5428698 or US5410625.

- 5 Devices of the type described with reference to figure 1 and 3 are conveniently formed as hollow channels in a silicon-based substrate using various known semiconductor micro-fabrication techniques; for example photolithography or deep dry etching. Silicon-based substrates suitable for use in the fabrication of such devices include bulk silicon, silicon on insulator (SOI), silicon on glass (SOG) and
10 silicon on sapphire (SOS). Alternatively, known micro-engineering techniques (e.g. hot embossing or laser ablation) can be used to form hollow channels in a layer, such as a polymer, located on the surface of the wafer.

15 The hollow channels may be provided with moveable side walls using micro-electromechanical systems (MEMS) technology; also termed microsystems technology (MST). Known actuation mechanisms used in MEMS include those employing electrostatic, electrothermal, electromagnetic, piezoelectric, electrostrictive, magnetostriuctive, bimetallic, shape memory alloy, chemical and physical (mechanical) properties. More detail on MEMS device actuation technologies and the associated fabrication techniques can be found in
20 "Fundamental of Microfabrication" by Marc Madou, published by CRC Press (Boca Raton) in 1997; ISBN 0-8493-9451-1.

25 In particular, the movable side walls may be implemented using technology presently used to provide MEMS movable mirrors. For example, see "MEMS and MOEMS Technology and Applications", P. Rai-Choudhury, SPIE (Bellingham), 2000 (ISBN 0-8194-3716-6) and "Micromachined transducers sourcebook", G.T.A. Kovacs, McGraw Hill (New York), 1998 (ISBN 0-07-290722-3). Known MEMS
30 movable mirrors vary in size from dimensions of the order of a few microns to several millimetres, and the amount of motion ranges from deep sub-micron to of the order of a few hundred microns. The amount of sidewall movement required to

implement the present invention (as described with reference to figure 5 below) can be readily obtained using such MEMS techniques.

It should be noted that the moveable side wall sections may be formed integrally
5 with the fixed side wall portions, or may be fabricated separately and integrated in a hybrid fashion to a substrate in which the fixed hollow channels are defined.

To ensure optimum device performance, the moveable side wall (or relevant portion
of the side wall) should be linearly translatable without inducing any significant
10 distortion to its shape. This can be accomplished by having an appropriate suspension system to effectively force a linear motion; i.e. a system which is compliant in the direction of desired motion but stiff to other (e.g. rotational) motions. A suitable suspension system can be provided using high aspect ratio (i.e. high depth to width ratio) springs to prevent twist. Similarly, the suspension
15 elements can be appropriately dimensioned with respect to the movable wall such that the translation is effectively accommodated entirely in the suspension (e.g. much more compliant) thereby preventing distortion.

As described in WO 03/065088 a reflective coating may also be applied to the
20 surfaces forming the hollow core waveguides to enhance reflectivity and thereby reduce optical losses associated with the device.

A person skilled in the art would appreciate that light can be coupled into or out of the fundamental mode waveguides of the devices described with reference to figure
25 1 to 4 in many ways. For example, optical routing devices of the present invention could be coupled to other optical components via optical fibre cables or could form an integral portion of a photonic integrated circuit of the type described WO 03/065091, the contents of which are incorporated herein by reference thereto.

30 Referring to figure 5, the amount of side wall movement that is required to impart a π phase shift to light propagating in a 10mm long fundamental mode waveguide is shown versus the waveguide width.

It is possible to consider any change in the width of the fundamental mode waveguide as a change in the effective refractive index of that waveguide. Within the paraxial approximation (i.e. where $(\lambda/2w)^2 \ll 1.0$), for light of wavelength λ ,
 5 the change in phase ($\partial\phi$) of the fundamental mode (EH₁₁) for a given change in waveguide width (∂w) can thus be expressed for a waveguide of length L and initial width w as:

$$\frac{\partial\phi}{\partial w} = \frac{L\pi\lambda}{2w^3} \quad (1)$$

10

The change in width of a fundamental mode waveguide to impart a π phase shift to the fundamental mode radiation propagating through that waveguide can thus be given by the expression:

15

$$\partial w = \frac{2w^3}{L\lambda} \quad (2)$$

20

Figure 5a shows a plot of waveguide width versus the change in waveguide width required to provide a π phase shift to light of $1.55\mu\text{m}$ wavelength for a waveguide 10mm in length for widths up to $50\mu\text{m}$. For ease of reference, figure 5b provides an expanded view of the data plotted in figure 1 for waveguide widths up to $10\mu\text{m}$.

25

Figure 5 thus shows that for a fundamental mode waveguide having a width of around $10\mu\text{m}$, a change in width of $0.1\mu\text{m}$ (i.e. around 1%) is required to impart the π phase shift required to implement an optical routing device of the type described with reference to figures 1 and 3. This level of waveguide width variation can be readily obtained using MEMS technology.

30

Although the movement of side walls of a substantially square cross-section waveguide is described above, it should be noted that the present invention can be applied to waveguides of any cross-sectional shape. It should also be noted that any

dimension of the waveguide, and not just the sidewall, may be altered to produce the required phase shift.

Claims

1. A hollow core multi-mode interference (MMI) device comprising a multi-mode waveguide optically coupled to at least two fundamental mode waveguides, characterised in that the device comprises a means for varying the internal cross-sectional dimensions of a portion of one or more of said at least two fundamental mode waveguides.
2. A device according to claim 1 wherein at least one of the fundamental mode waveguides has a substantially square cross-section.
3. A device according to any one of the preceding claims wherein the internal surfaces of the hollow core waveguides are coated with at least one layer of reflective material.
4. A device according to any one of the preceding claims wherein the device is formed in a semiconductor material.
5. A device according to claim 4 wherein the device is formed in silicon.
6. A device according to any one of the preceding claims wherein the means for varying the cross-sectional dimensions of a portion of said fundamental mode waveguide comprises micro-electro-mechanical (MEMS) actuation means.
7. A device for routing radiation comprising at least one device according to any one of the preceding claims.
8. A device according to any one of claims 1 to 5 wherein the means for varying the internal cross-sectional dimensions of a portion of said fundamental mode waveguide are arranged such that the fundamental mode waveguide dimensions can be varied by application of an external force.

9. An optical router comprising;

at least one fundamental mode input waveguide optically coupled to an MMI beam splitter, the MMI beam splitter also being optically coupled, via two or more relay waveguides, to an MMI beam recombiner having two or more fundamental mode output waveguides,

wherein the relay waveguides comprise a means for altering the relative phases between the two or more beams propagating though the relay waveguides such that radiation received from the fundamental mode input waveguide may be selectively routed to any one of the two or more fundamental mode output waveguides,

characterised in that the means for altering the relative phases between the two or more beams comprises a means for varying the cross-sectional dimensions of a portion of one or more of the relay waveguides.

10. An optical router comprising

a multi-mode waveguide region optically coupled to a plurality of input/output fundamental mode waveguides and a plurality of relay waveguides,

the router being configured to receive a beam of radiation via one of the plurality of input/output fundamental mode waveguides and, via modal dispersion in the multi-mode waveguide region, to divide the received beam into a plurality of beams that are coupled in to the relay waveguides,

wherein the relay waveguides comprise a means for altering the relative phases between the plurality of beams and each relay waveguide is terminated with a reflective means such that radiation is returned to the multimode waveguide region and, dependent on the relative phases of the returned beams, routed to any one of the input/output fundamental mode waveguides,

characterised in that the means for altering the relative phases between the plurality of beams comprises a means for varying the cross-sectional dimensions of a portion of one or more of the relay waveguides.

11. An optical phase shifter comprising a hollow core optical waveguide, characterised in that the phase shifter comprises means for varying the internal cross-sectional dimensions of a portion of said hollow core optical waveguide.

1/3

Fig.1.

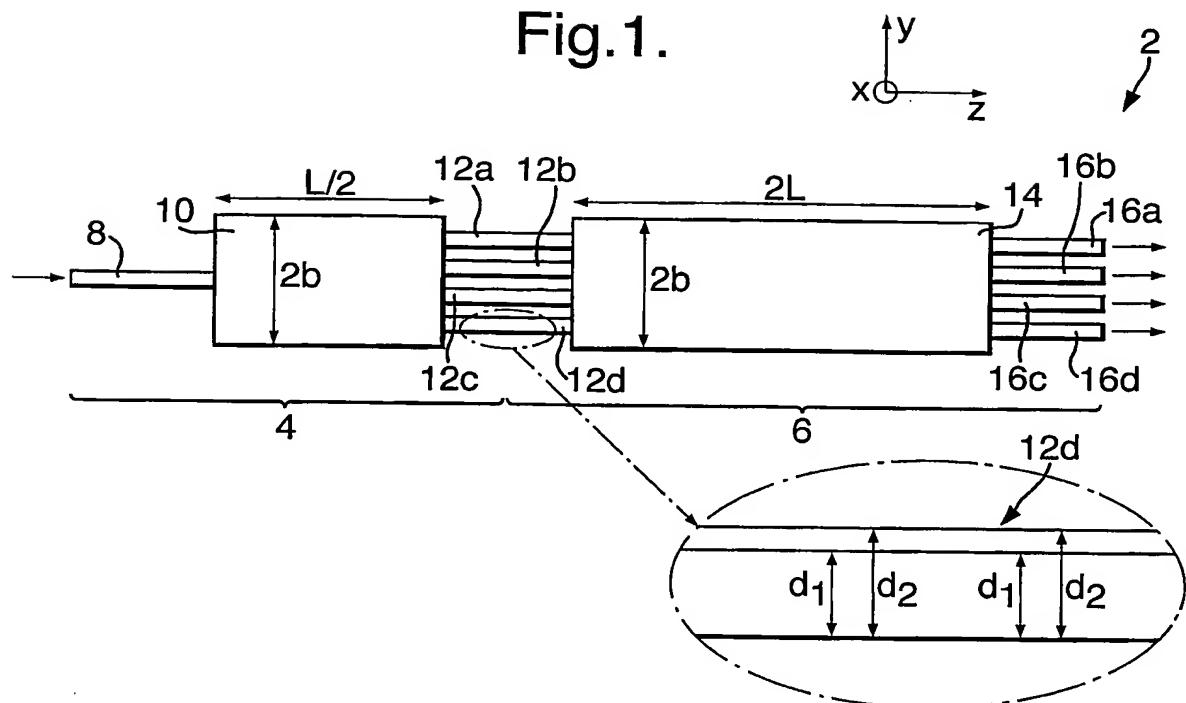


Fig.2a.

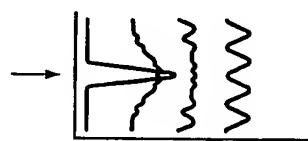


Fig.2b.

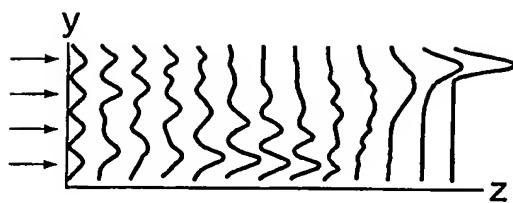
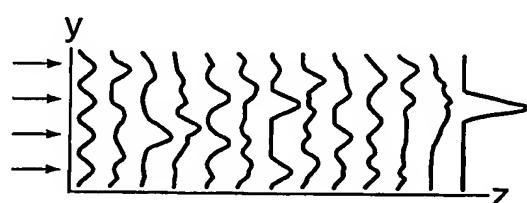


Fig.2c.



2/3

Fig.3.

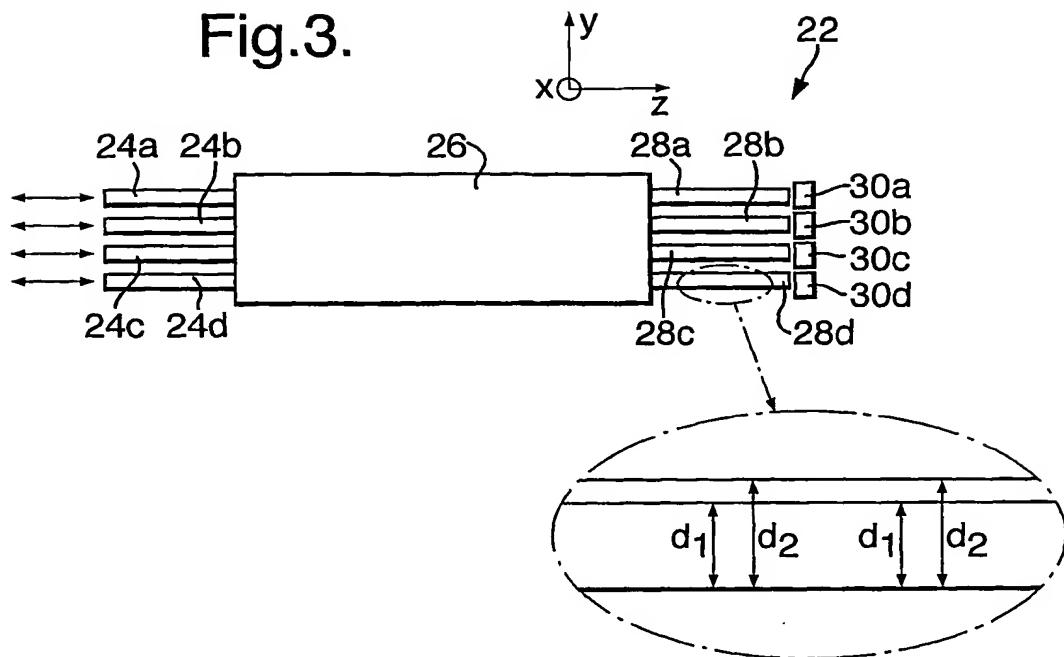


Fig.4a.

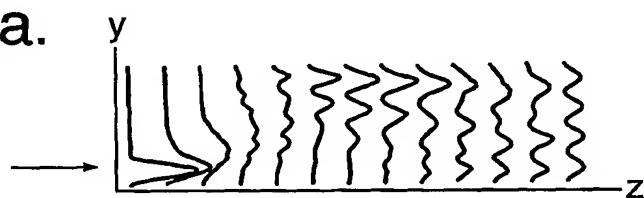


Fig.4b.

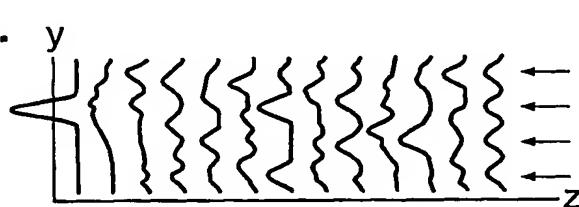
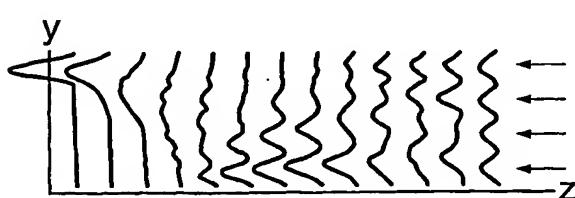


Fig.4c.



3/3

Fig.5a.

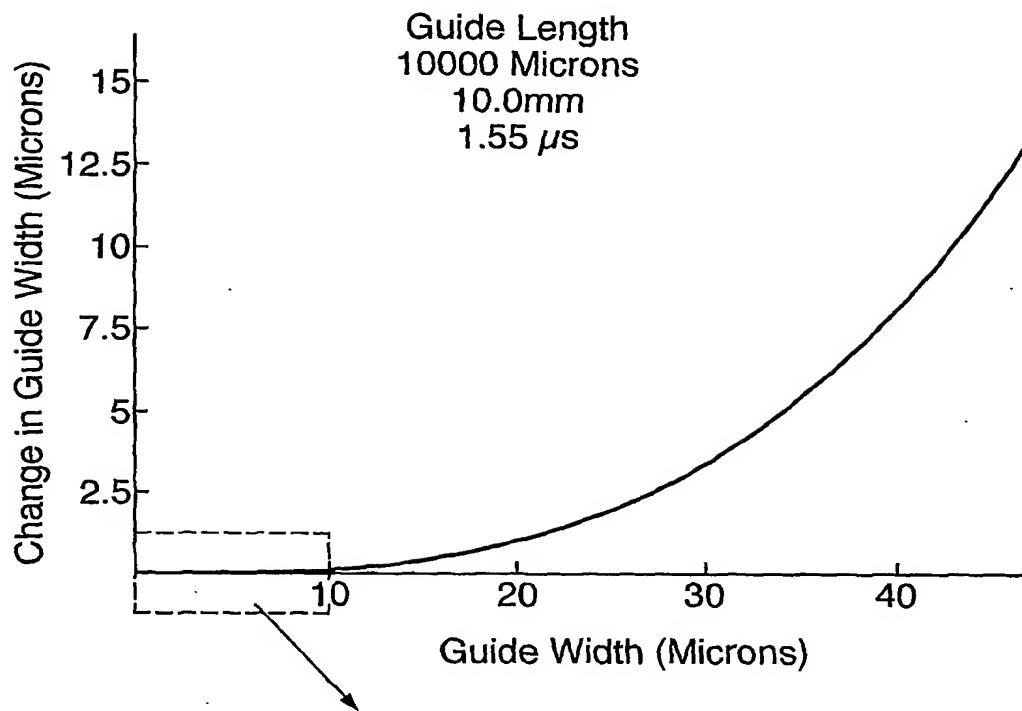
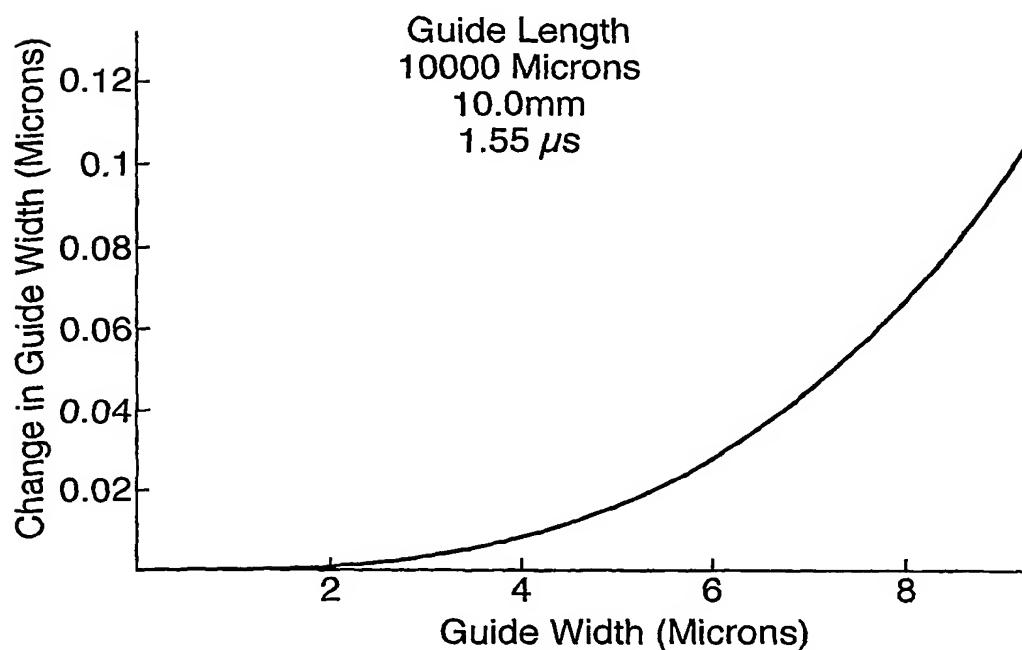


Fig.5b.



INTERNATIONAL SEARCH REPORT

International Application No
PCT/GB 03/04723

A. CLASSIFICATION OF SUBJECT MATTER
IPC 7 G02B6/28 G02B6/12 G02B26/00

According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols)
IPC 7 G02B

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Electronic data base consulted during the international search (name of data base and, where practical, search terms used)

EPO-Internal, WPI Data, PAJ, COMPENDEX, INSPEC

C. DOCUMENTS CONSIDERED TO BE RELEVANT

Category *	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
A	EP 0 903 616 A (LUCENT TECHNOLOGIES INC) 24 March 1999 (1999-03-24) paragraphs '0020!, '0021! figure 7 -----	10
A	SAIDA T ET AL: "SILICA-BASED 2X2 MULTIMODE INTERFERENCE COUPLERS WITH ARBITRARY POWER SPLITTING RATIO" EXTENDED ABSTRACTS OF THE INTERNATIONAL CONFERENCE ON SOLID STATE DEVICES AND MATERIALS, JAPAN SOCIETY OF APPLIED PHYSICS. TOKYO, JA, 1999, pages 458-459, XP000935168 the whole document ----- -/-	1,9,11

Further documents are listed in the continuation of box C.

Patent family members are listed in annex.

* Special categories of cited documents :

- *A* document defining the general state of the art which is not considered to be of particular relevance
- *E* earlier document but published on or after the international filing date
- *L* document which may throw doubts on priority claim(s) or which is cited to establish the publication date of another citation or other special reason (as specified)
- *O* document referring to an oral disclosure, use, exhibition or other means
- *P* document published prior to the international filing date but later than the priority date claimed

- *T* later document published after the international filing date or priority date and not in conflict with the application but cited to understand the principle or theory underlying the invention
- *X* document of particular relevance; the claimed invention cannot be considered novel or cannot be considered to involve an inventive step when the document is taken alone
- *Y* document of particular relevance; the claimed invention cannot be considered to involve an inventive step when the document is combined with one or more other such documents, such combination being obvious to a person skilled in the art.
- *&* document member of the same patent family

Date of the actual completion of the international search

24 February 2004

Date of mailing of the international search report

04/03/2004

Name and mailing address of the ISA

European Patent Office, P.B. 5818 Patentlaan 2
NL - 2280 HV Rijswijk
Tel. (+31-70) 340-2040, Tx. 31 651 epo nl,
Fax: (+31-70) 340-3016

Authorized officer

Verdrager, V

INTERNATIONAL SEARCH REPORT

International	Application No
PCT/GB 03/04723	

C.(Continuation) DOCUMENTS CONSIDERED TO BE RELEVANT

Category	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
A	LEE S ET AL: "INGAAS/INP MULTIMODE INTERFERENCE SPLITTER WITH VARIABLE SPLITTING RATIO" PROCEEDINGS OF THE SPIE, SPIE, BELLINGHAM, VA, US, vol. 3944, 24 January 2000 (2000-01-24), pages 673-678, XP009018192 ISSN: 0277-786X abstract page 673, paragraph 4 -page 674, paragraph 1 page 675, paragraph 1 figure 3	1,9,11
A	DANGEL R ET AL: "Electro-nanomechanically actuated integrated-optical interferometric intensity modulators and 2x2 space switches" OPTICS COMMUNICATIONS, NORTH-HOLLAND PUBLISHING CO. AMSTERDAM, NL, vol. 156, no. 1-3, 1 November 1998 (1998-11-01), pages 63-76, XP004143048 ISSN: 0030-4018 abstract page 72, paragraph 3	1,6,11
P,A	WO 03 065088 A (JENKINS RICHARD MICHAEL ;MCNIE MARK EDWARD (GB); QINETIQ LTD (GB)) 7 August 2003 (2003-08-07) cited in the application page 9, line 17-24 page 20, line 23 -page 21, line 21 page 23, line 1-16	1-6,9-11
A	US 5 428 698 A (JENKINS RICHARD M ET AL) 27 June 1995 (1995-06-27) cited in the application column 2, line 40-60 column 9, line 7 -column 10, line 29 column 13, line 46-50	1-6,9-11
A	US 5 379 354 A (JENKINS RICHARD M) 3 January 1995 (1995-01-03) cited in the application column 5, line 65 -column 6, line 50 column 11, line 34-40 column 12, line 52-64	1-6,9-11

Information on patent family members				International application No	
Patent document cited in search report	Publication date	Patent family member(s)		Publication date	
EP 0903616	A 24-03-1999	US DE DE EP JP	5953467 A 69808867 D1 69808867 T2 0903616 A2 11160742 A	14-09-1999 28-11-2002 18-06-2003 24-03-1999 18-06-1999	
WO 03065088	A 07-08-2003	WO	03065088 A2	07-08-2003	
US 5428698	A 27-06-1995	CA DE DE EP WO JP JP JP	2096421 A1 69126887 D1 69126887 T2 0563065 A1 9211551 A1 6503898 T 3361520 B2 2003035918 A	21-06-1992 21-08-1997 08-01-1998 06-10-1993 09-07-1992 28-04-1994 07-01-2003 07-02-2003	
US 5379354	A 03-01-1995	CA DE DE EP WO JP JP	2096422 A1 69129120 D1 69129120 T2 0563068 A1 9211554 A2 3188695 B2 6503899 T	21-06-1992 23-04-1998 08-10-1998 06-10-1993 09-07-1992 16-07-2001 28-04-1994	